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	Application No.	Applicant(s)
Notice of Allowability	09/305,722	BAO ET AL.
	Examiner	Art Unit
	Anita K Alanko	1765
The MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject t	plication. If not included n will be mailed in due course. THIS
1. This communication is responsive to 10/31/03.		
2. The allowed claim(s) is/are 1,3-5,7-9,11,12 and 19.		
<ul> <li>3.  The drawings filed on <u>11/30/00</u> are accepted by the Exami</li> <li>4.  Acknowledgment is made of a claim for foreign priority ur</li> </ul>		
a) ☐ All b) ☐ Some* c) ☐ None of the:	ider 35 0.5.C. § 119(a)-(0) or (1).	
Certified copies of the priority documents have	been received.	
<ol><li>Certified copies of the priority documents have</li></ol>	been received in Application No	·
<ol><li>Copies of the certified copies of the priority do</li></ol>	cuments have been received in this	national stage application from the
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
<ol> <li>Acknowledgment is made of a claim for domestic priority un reference was included in the first sentence of the specifica</li> </ol>	ation or in an Application Data Sheet	ional application) since a specific t. 37 CFR 1.78.
(a) The translation of the foreign language provisional a		
<ol> <li>Acknowledgment is made of a claim for domestic priority up in the first sentence of the specification or in an Application</li> </ol>	nder 35 U.S.C. §§ 120 and/or 121 s Data Sheet, 37 CFR 1.78,	ince a specific reference was included
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of	this communication to file a reply on this application. THIS THREE-MO	omplying with the requirements noted NTH PERIOD IS NOT EXTENDABLE
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give</li> </ol>	itted. Note the attached EXAMINER es reason(s) why the oath or declara	'S AMENDMENT or NOTICE OF ation is deficient.
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") mus         <ul> <li>(a) ☐ including changes required by the Notice of Draftspers</li> <li>1) ☐ hereto or 2) ☐ to Paper No</li> </ul> </li> </ol>		948) attached
(b) $\square$ including changes required by the proposed drawing c	orrection filed, which has be	en approved by the Examiner.
(c) ☐ including changes required by the attached Examiner's	Amendment / Comment or in the C	Office action of Paper No
Identifying Indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in t	84(c)) should be written on the drawin ne margin according to 37 CFR 1.121(	ngs in the front (not the back) of d).
<ol> <li>DEPOSIT OF and/or INFORMATION about the depos attached Examiner's comment regarding REQUIREMENT FOR T</li> </ol>	sit of BIOLOGICAL MATERIAL r HE DEPOSIT OF BIOLOGICAL MA	nust be submitted. Note the TERIAL.
Attachment(s)		
1☐ Notice of References Cited (PTO-892)	5☐ Notice of Informal Pa	tent Application (PTO-152)
2 Notice of Draftperson's Patent Drawing Review (PTO-948)		PTO-413), Paper No
3 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No.	), 7☐ Examiner's Amendm	ent/Comment
4 Examiner's Comment Regarding Requirement for Deposit of Biological Material		t of Reasons for Allowance
or biological ivialerial	9□ Other .	Anita K. Hemly
		Anita K Alanko Primary Examiner Art Unit: 1765

Art Unit: \*\*\*

CLMPTO

12/17/03

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1.(Previously Amended) A method for forming at making an organic transistor on a substrate comprising the steps of:

providing a substrate including a metal surface layer;

providing a rotatable stamp having relief geometries on its surface to define a stamping surface;

applying a self-assembled monolayer ink to the surface of the rotatable stamp to define an inked stamping surface;

rotating the rotatable stamp on the metal surface layer as the layer is placed in contact with the stamp to impress on the layer an inked pattern as defined by the inked stamping surface; and

patterning the layer by etching material from the layer wherein the inked stamping surface guides the etching in a geometry to define the patterned layer useful in fabricating an electronic device;

removing the inked pattern from the layer; and applying an organic semiconductor layer overlying the etched metal layer.

Claim 2 is canceled.

- 3.(Original) The method of claim 1, in which the step of providing the rotatable stamp comprises:
  - (a) casting a liquid onto a surface having relief geometries thereon;
  - (b) solidifying the liquid to define a solid film; and
- (c) rolling a member over the solid film so that the solid film is lifted from the surface and bonds to the member.
- 4.(Original) The method of claim 3, in which the liquid comprises an elastomeric material, the step of solidifying the liquid comprises curing the elastomeric material to form an elastomeric film.
- 5.(Original) The method of claim 4, further comprising a step of exposing the cured elastomeric film to oxygen plasma before the member is rolled over the film.
  Claim 6 is canceled.
  - 7.(Currently Amended) The method of claim [6] <u>1</u> in which the <u>metal surface</u> <u>layer</u> [at least one coating layer] includes a thin layer of gold or silver.
  - 8.(Previously Amended) The method of claim 1 in which the step of patterning the metal layer comprises etching material from the substrate applying an etchant selected from the group consisting of aqueous ferrocyanide, K<sub>4</sub>Fe(CN)<sub>6</sub>, K<sub>3</sub>Fe(CN)<sub>6</sub>, Na<sub>2</sub>S<sub>2</sub>O<sub>3</sub>, and KOH in H<sub>2</sub>O.

9.(Original) The method of claim 1, in which the step of rotating the stamp provides an exposed region on the metal layer where substantially no ink is present and a protected region on the layer where ink substantially covers protected region.

Claim 10 is canceled.

11. The method of claim [10] 1, in which the metal <u>surface</u> layer has an applied adhesive layer selected from the group consisting of Ti and Cr.

12.(Previously Amended) The method of claim 1 in which the inked pattern is removed by ultraviolet light, heat, or wet chemical cleaning.

Claims 13-18 are canceled.

19.(Previously Amended) The method of claim 3 wherein the member comprises a cylinder with a glass surface.

Claims 20-22 are canceled.